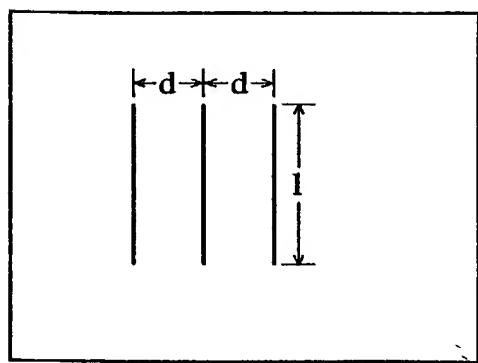


Title: AN ELECTRON BEAM DEVICE FOR OPTICAL MEASUREMENTS  
AND METHOD FOR STEREOSCOPIC  
MEASUREMENTS

Inventor(s): Nobuo KOCHI et al.  
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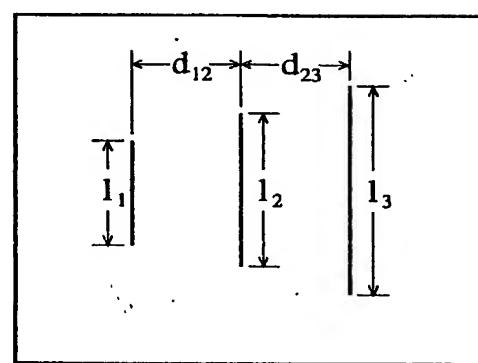
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*FIG.1 (A)*



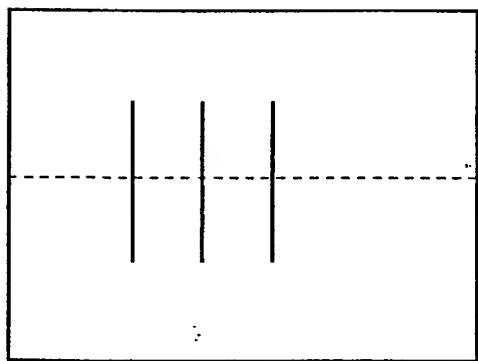
0 degree

*FIG.1 (B)*

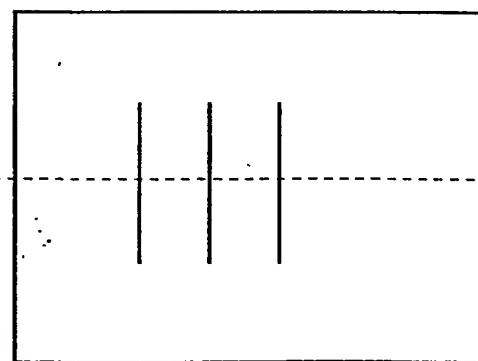


10 degrees

*FIG.2 (A)*



*FIG.2 (B)*



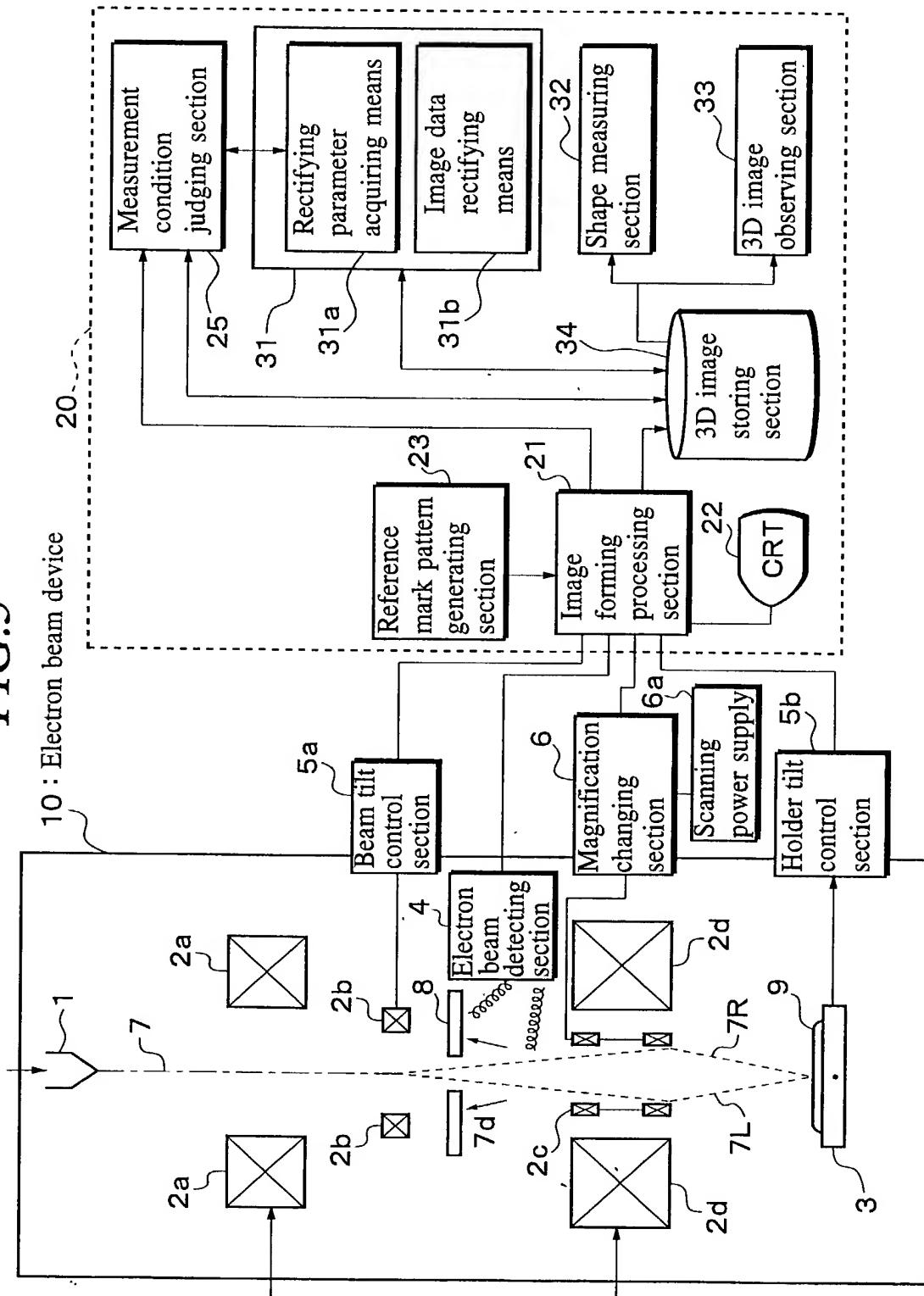
Epipolar line

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FIG.3



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FIG.4 (A)

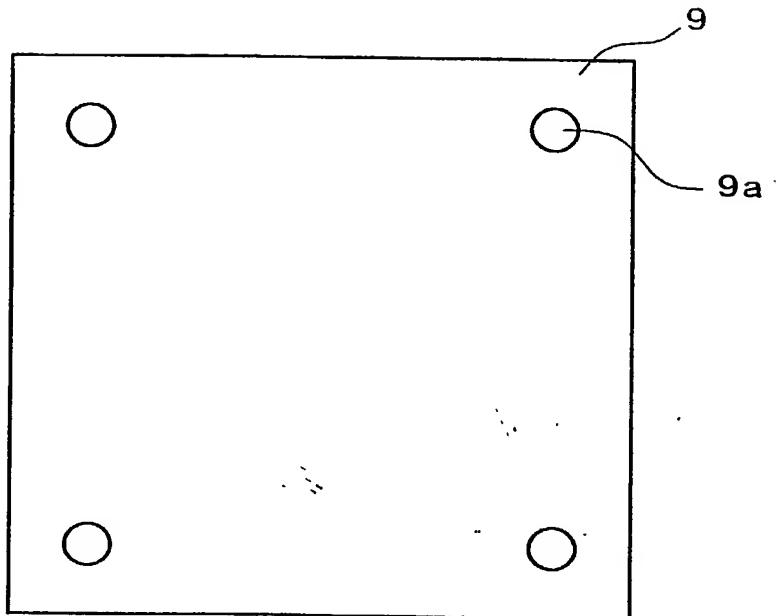


FIG.4 (B)

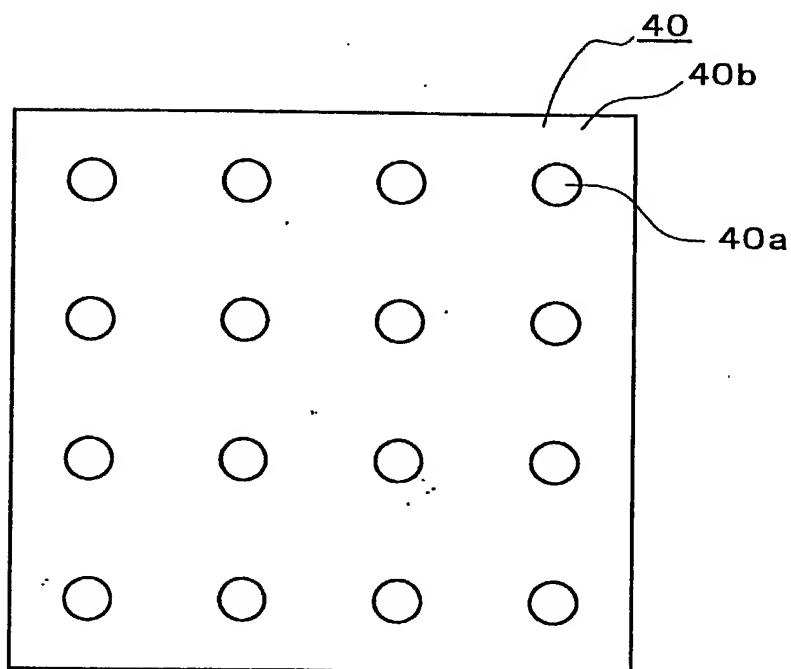
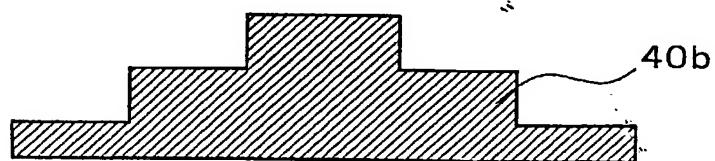
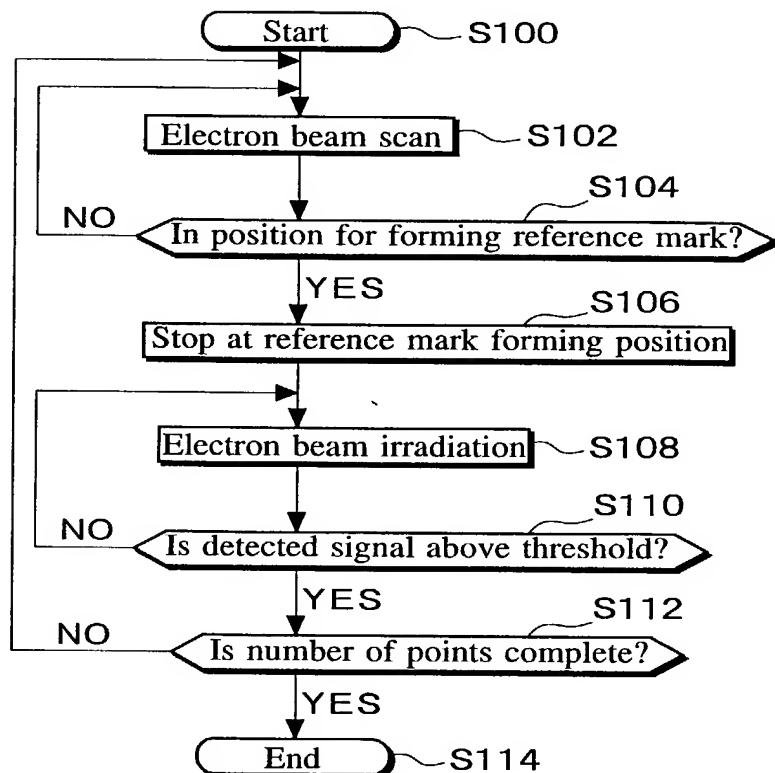


FIG.4 (C)



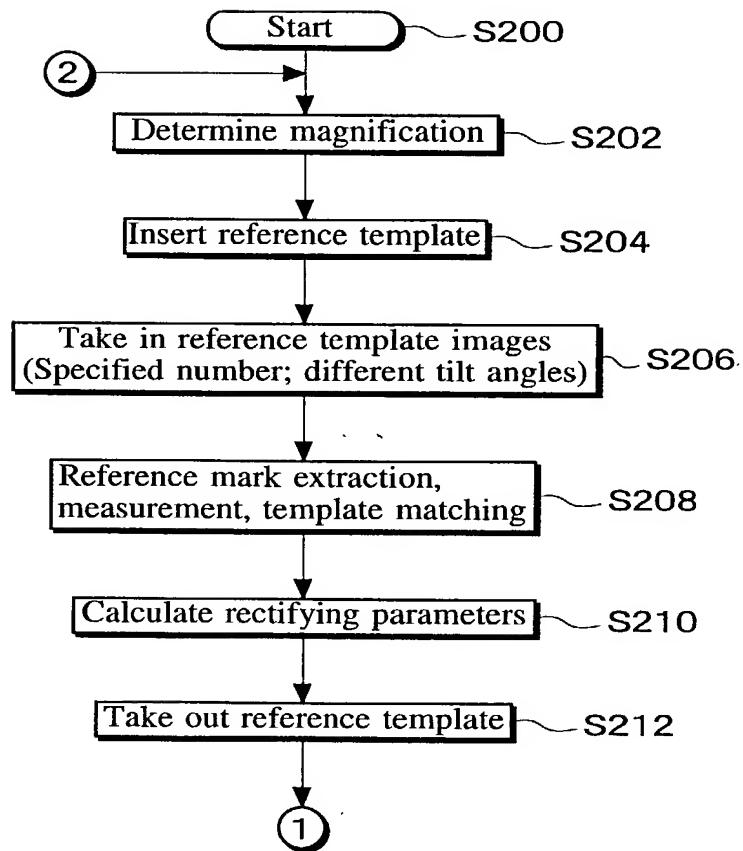
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**FIG.5**

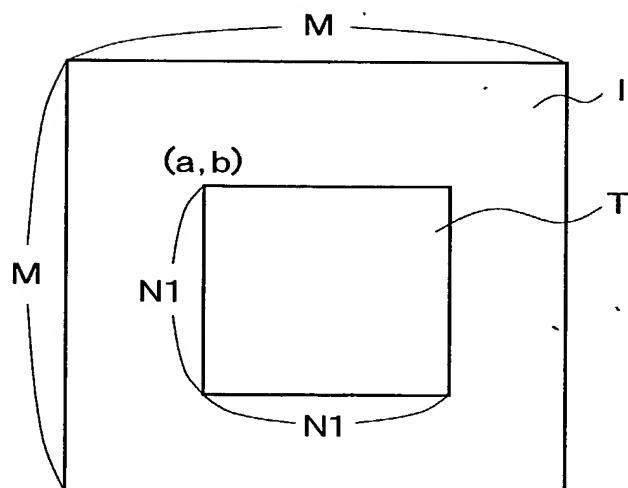


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**FIG.6**

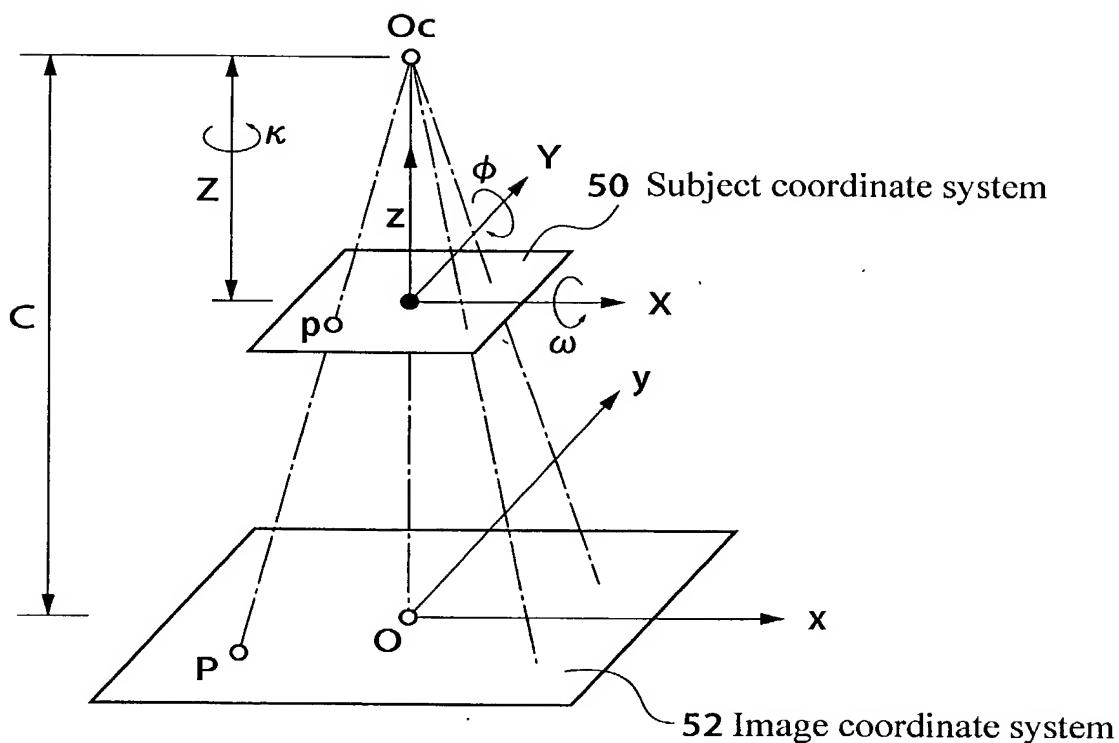


**FIG.7**



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FIG. 8



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*FIG.9*

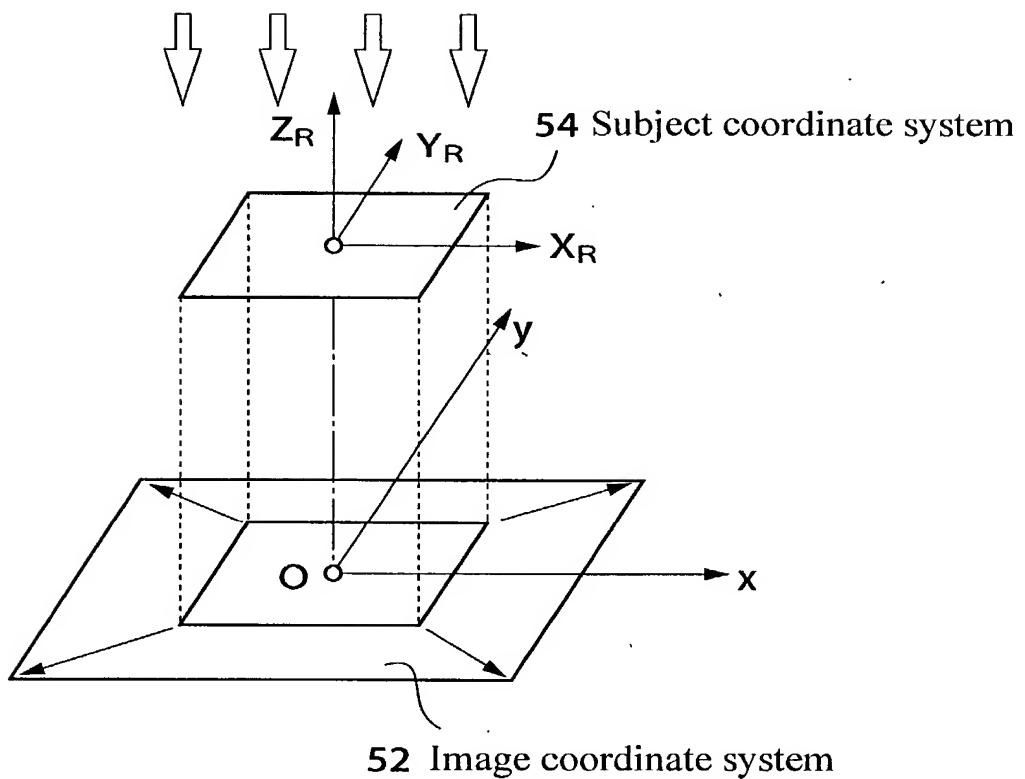


FIG.10

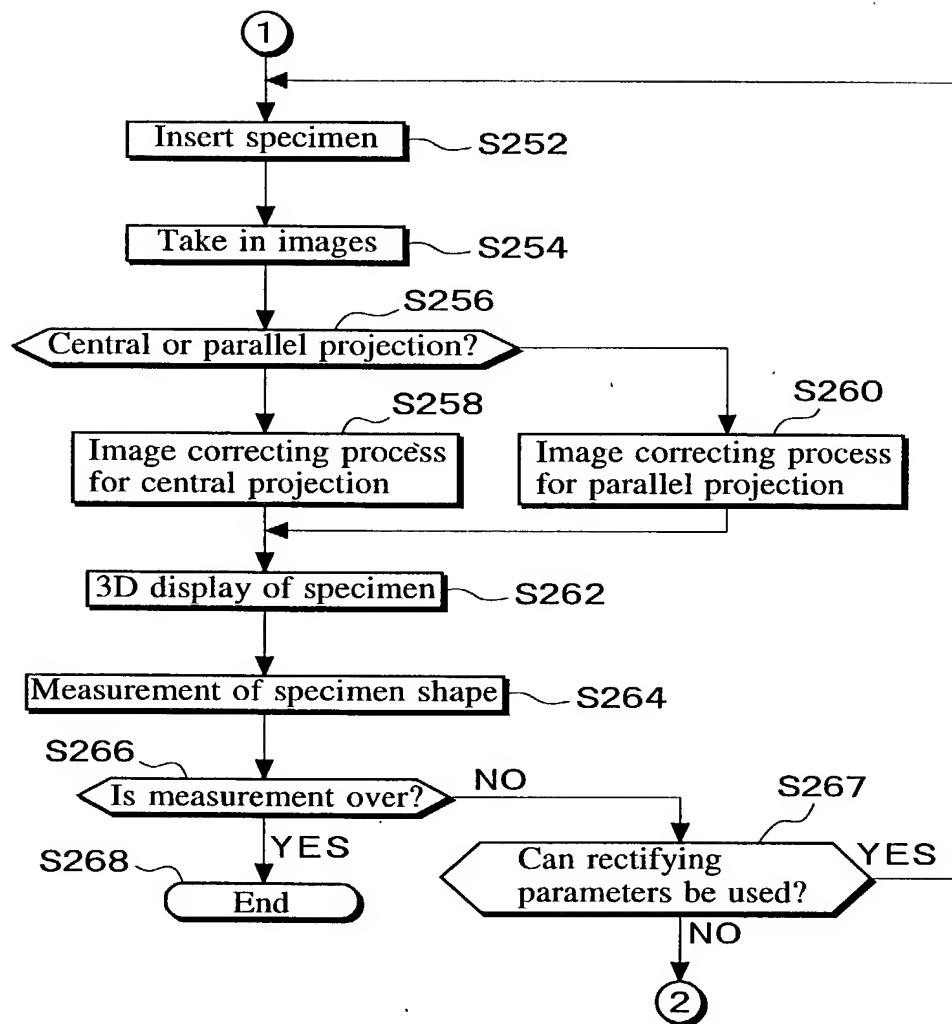
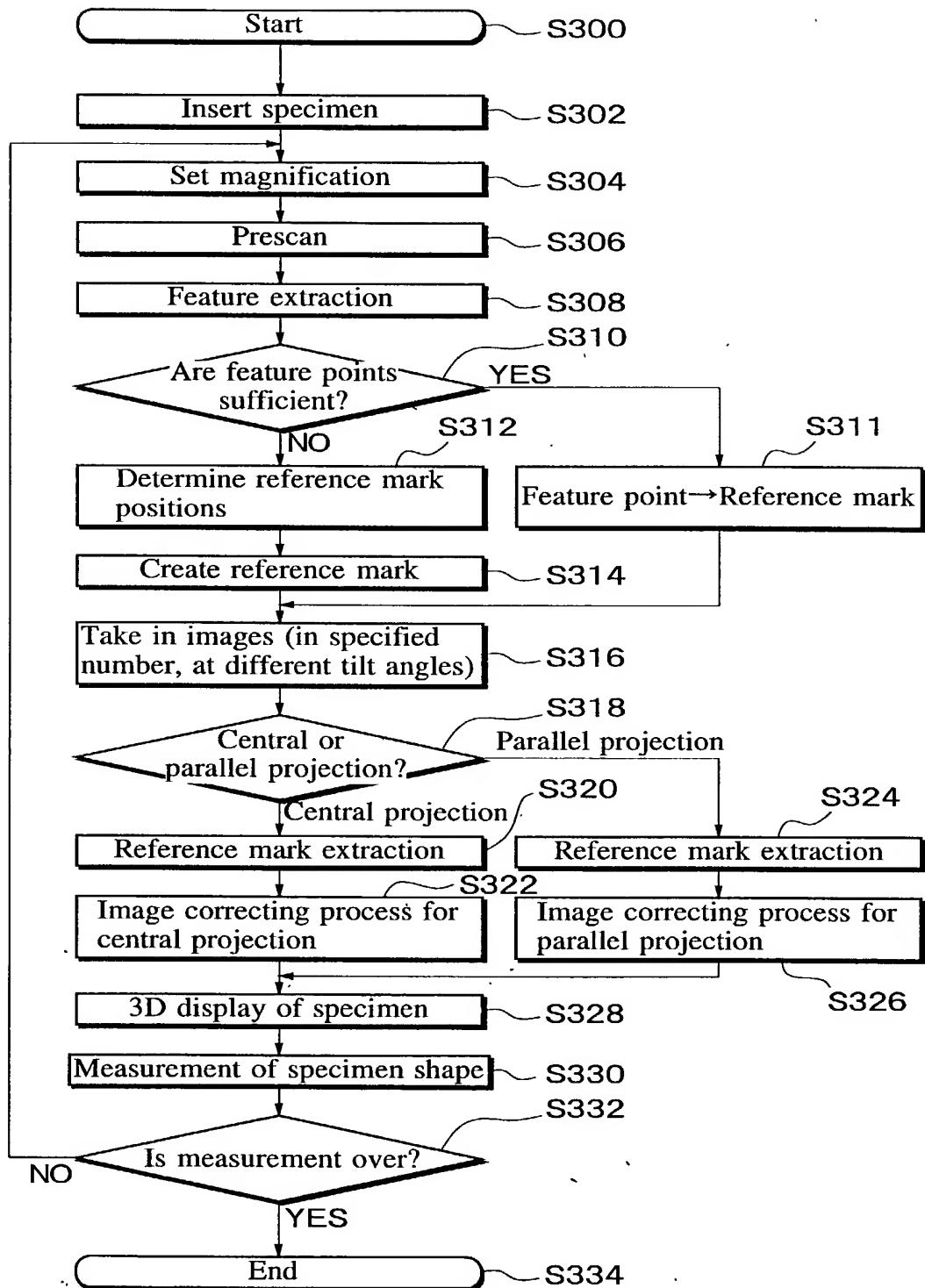


FIG.11



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*FIG.12 (A)*

Laplacean operator

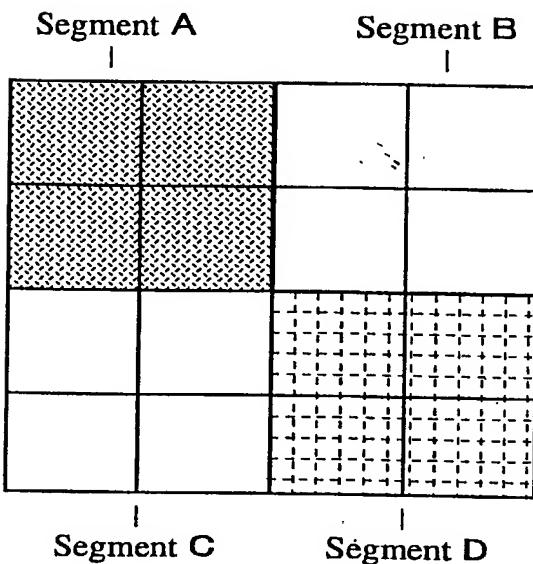
0	-1	0
-1	5	-1
0	-1	0

*FIG.12 (B)*

Line detecting operator

-1/2	1	-1/2
-1/2	1	-1/2
-1/2	1	-1/2

*FIG.13*



*FIG.14*

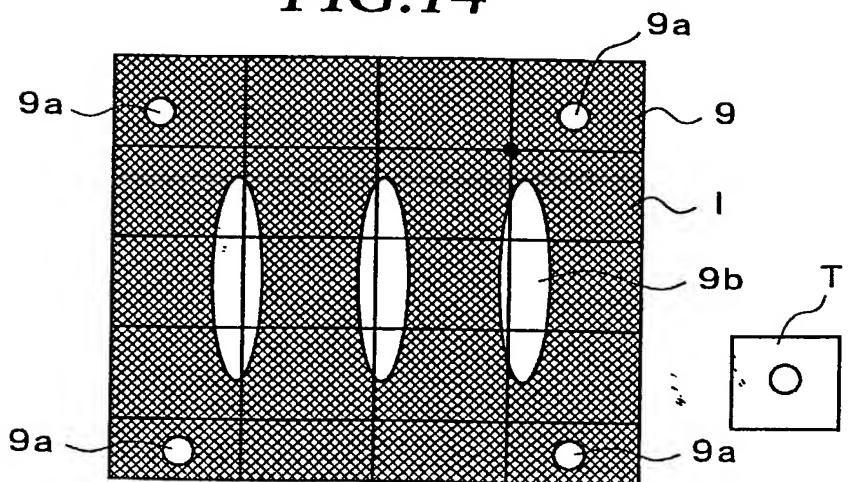
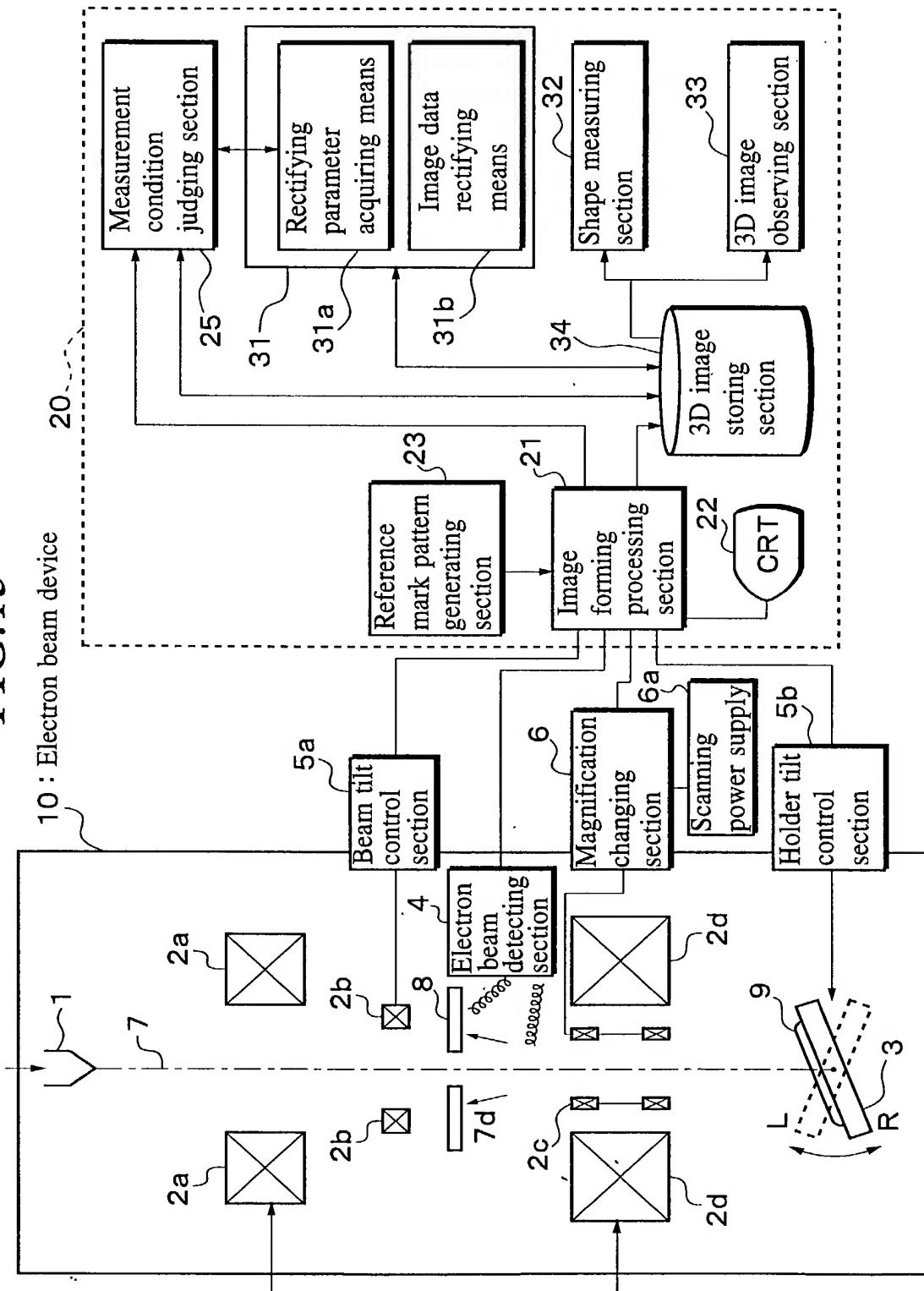


FIG. 15



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FIG. 16

